

S/N 10/681,481

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar

Examiner: Joy L. Watson

Serial No.: 10/681,481

Group Art Unit: 1792

Filed: October 8, 2003

Docket No.: 1303.112US1

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Office Action mailed on February 12, 2008. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from May 12, 2008 to June 12, 2008.